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Application/Control No.	Applicant(s)/Patent under Reexamination
10/602,848	TANAKA ET AL.
Examiner	Art Unit
W. Patty Chen	2871

	SEARCHED				
Class	Subclass	Date	Examiner		
349	40	9/28/2006	WPC		
349	147	9/28/2006	WPC		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH)		)
	DATE	EXMR
Citations search of relevant references	9/28/2006	WPC
349/147 combined with 349/148 search of all databases in EAST	9/28/2006	WPC
349/147 combined with 349/152 search of all databases in EAST	9/28/2006	WPC
349/152 combined with 349/148 search of all databases in EAST	9/28/2006	WPC
349/147-152 combined with key words search of all databases in EAST	9/28/2006	WPC
Consulted Primary Examiner Andrew Schechter in interpreting claims	9/28/2006	WPC